WBB2 16:00 – 16:15

Magneto-optic Contact for Application in an Amplifying Waveguide Optical Isolator

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Abstract: We present the development of a metal-semiconductor contact for a TM-mode amplifying waveguide optical isolator and show that it is a compromise between good (magneto-)optical performance and good electrical behavior.

An optical isolator is indispensable in a telecom link to protect the laser sources against back-reflected light. A waveguide version of this component is highly desirable as it would decrease the packaging cost – hence the overall cost – of a laser diode module largely. An approach that is getting a lot of attention in recent years [1-2] involves the use of a ferromagnetic metal as the source of the non-reciprocal effect. In an optical waveguide covered with a transversely magnetized ferromagnetic metal film close to the guiding region, the magneto-optic (MO) Kerr effect induces a non-reciprocal shift of the complex effective index of the guided mode. In other words, the modal loss is dependent on the propagation direction of the light. If the guiding core consists of amplifying layers, electrical biasing decreases the internal loss of the waveguide. The result is a device which, being transparent in the forward while providing loss in the opposite direction, is isolating. As the isolator basically has the same structure as the laser it is to be integrated with, monolithic integration is straightforward. In the simplest configuration, illustrated in figure 1 and operating for TM-polarized light, the ferromagnetic metal acts as the electrical contact for the underlying semiconductor optical amplifier. Therefore, an important issue that needs to be solved is the development of an ohmic electrical contact for application in this optical isolator. In this paper we show that a compromise needs to be made between good optical and MO performance and good electrical behavior.

A metal-semiconductor contact is said to be ohmic if the contact does not influence the contacted device, that is if the contact resistivity is small (order $10^{-5}\Omega cm^2$). The contact resistivity decreases with increasing dopant levels of the semiconductor layer in contact with the metal and with decreasing barrier height between metal and semiconductor. Due to pinning of the Fermi-level in III-V semiconductors the barrier height is quasi-independent of the workfunction of the metal, hence the unusual choice of the contact metal – a ferromagnetic metal – is not expected to deteriorate the contact quality. Furthermore, the barrier height decreases with diminishing bandgap energy of the semiconductor layer. The material lattice-matched to InP with the lowest bandgap is $In_{0.53}Ga_{0.47}As$, hence the standard electrical contact of an amplifying device is composed of a highly doped $In_{0.53}Ga_{0.47}As$ layer between the cladding and the metal. For the amplifying waveguide isolator the situation is more complicated. As the isolator performance is determined by the overlap of the guided mode with the ferromagnetic metal, it is fundamental that the semiconductor contact structure is transparent or at least little absorbing. At the operation wavelength of 1300nm, the absorption level of $In_{0.53}Ga_{0.47}As$ equals $1.55x10^4cm^{-1}$, making a standard contact structure not suitable for the isolator. We have examined four alternative contact structures (table 1), using a standard contact as the reference.

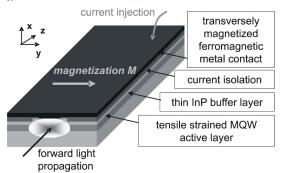
The influence of the contact structure on the optical and MO properties of the isolator was estimated through simulation of an isolator benchmark example with each of the five contact structures of table 1. Calculations have been done with the mode solver CAMFR [3] extended with a perturbation-based algorithm for MO waveguide calculation [4]. The experimental values of the optical and MO parameters of the ferromagnetic metal $Co_{50}Fe_{50}$ served as input for these simulations. The important figure of merit for this type of device is the ratio between the non-reciprocal loss and the remaining loss in the forward propagation direction, the 'isolation-to-loss ratio'. The outcome of these simulations is plotted in figure 2. It can immediately be concluded that the absorption in the ternary $In_{0.53}Ga_{0.47}As$ contact layer seriously decreases the performance of the isolator, hence from (magneto-)optical point of view it is best to use a purely quaternary $In_{0.81}Ga_{0.19}As_{0.41}P_{0.59}$ contact. Furthermore, the thickness of the quaternary contact layer must be large enough for the isolation-to-loss ratio to be maximal. The explanation for this is that the phase of the transverse electric field component at the metal-semiconductor interface is then better matched to the complex argument of the off-diagonal elements of the permittivity tensor of $Co_{50}Fe_{50}$ [5].

For the extraction of the electrical quality of the five contact structures, cross-bridge Kelvin resistors [6] have been fabricated. Be p^{++} -doped $In_{0.81}Ga_{0.19}As_{0.41}P_{0.59}$ ($N_{Be} = 2x10^{19} cm^{-3}$) and $In_{0.53}Ga_{0.47}As$ ($N_{Be} = 3x10^{19} cm^{-3}$) layers with gas source molecular beam epitaxy (GSMBE) on an InP substrate. Whereas such high dopant levels are standard for $In_{0.53}Ga_{0.47}As$, this is not the case for $In_{0.81}Ga_{0.19}As_{0.41}P_{0.59}$, but we succeeded by growing the quaternary material at low temperature ($T_s = 460^{\circ}C$). A 50nm thick $Co_{50}Fe_{50}$ MO metal layer was then sputtered and topped with a Ti/Au protective bilayer (40nm/150nm). Rapid thermal processing (RTP), which is known to improve the contact quality [7], was carried out at temperatures between 250°C and 450°C, in a forming gas (N_2 : H_2) atmosphere (duration, 30 seconds). With the aid of a MATLAB algorithm [6] we were able to extract the contact resistivity very accurately. As is illustrated in figure 3 a purely quaternary contact (Q1 and Q2) has a too high value of the contact resistivity, but the contact quality of a standard ternary contact can be well approached by topping a 100nm $In_{0.81}Ga_{0.19}As_{0.41}P_{0.59}$ layer with a 15nm $In_{0.53}Ga_{0.47}As$ layer (H1 scheme) and performing RTP at 350°C. Now, as the (magneto-)optical performance of this H1 scheme is much better than that of a standard structure (figure 2), it can be concluded that the hybrid H1 contact scheme is the preferred ohmic electrical contact for the amplifying waveguide optical isolator. With that, we have solved one of the important issues towards an integratable optical isolator.

Acknowledgement

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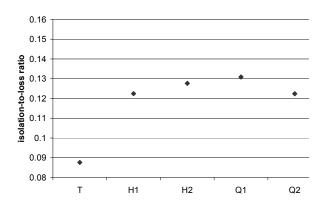
Figures



label	composition	thickness (nm)	Be dopant concentration (cm ⁻³)
T	$In_{0.53}Ga_{0.47}As$	100	$3x10^{19}$
H1	$\begin{array}{c} In_{0.81}Ga_{0.19}As_{0.41}P_{0.59} \\ /\ In_{0.53}Ga_{0.47}As \end{array}$	100 / 15	2x10 ¹⁹ / 3x10 ¹⁹
Н2	$\begin{array}{c} In_{0.81}Ga_{0.19}As_{0.41}P_{0.59} \\ /\ In_{0.53}Ga_{0.47}As \end{array}$	100 / 5	$2x10^{19} / 3x10^{19}$
Q1	$In_{0.81}Ga_{0.19}As_{0.41}P_{0.59}$	100	$2x10^{19}$
Q2	$In_{0.81}Ga_{0.19}As_{0.41}P_{0.59}$	50	2x10 ¹⁹

Fig. 1: Lay-out of the amplifying waveguide optical isolator.

Table 1: Specifications of the five semiconductor contact structures.



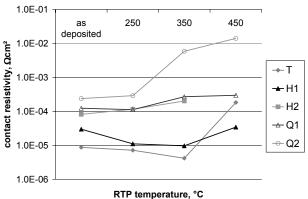
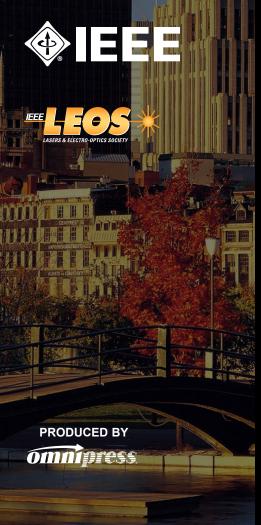


Fig. 2: Simulated isolation-to-loss ratio for the five contact structures.

Fig. 3: Extracted contact resistivity for different RTP temperatures, for all five contact structures.

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